



14/B w/2003  
5/13/03  
D. Bell

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Katsura Otaki

Group Art Unit: 2877

Application No.: 09/780,414

Examiner: S. Turner

Filed: February 12, 2001

Docket No.: 108598

For: POINT DIFFRACTION INTERFEROMETER FOR MEASURING PROFILE  
IRREGULARITIES (AS AMENDED)

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action mailed February 13, 2003, please amend the above-identified application as follows:

**Amendments to the Specification;**

**Amendments to the Claims** are reflected in the listing of claims;

**Amendments to the Drawings** include an attached replacement sheet; and

**Remarks.**

RECEIVED  
MAY 13 2003  
TECHNOLOGICAL CENTER 2800